

LIST OF ART CITED BY APPLICANT				ATTY. DOCKET NO.		SERIAL NO.	
(PTO-1449)				521.41463X00 (8088-0034)		09925,626	
				APPLICANT		FEB 12 2003	
				Oka et al.		PATENT & TRADEMARK OFFICE	
				FILING DATE		GROUP	
				August 10, 2001		2811	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
SK	5,797,999	8/25/98	Sannomiya et al.	136	258	9/6/96	
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
SK	09-82997	3/28/97	Japan			Yes	No
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
SK	Yamamoto et al. Central Research Laboratories, Kaneka Corporation, Japan "Thin-Film Polycrystalline Si Solar Cell on Glass Substrate Fabricated by a Novel Low Temperature Process" IEEE, December 5-9, 1994, ppgs. 1575-1578						
EXAMINER				DATE CONSIDERED			
Shearny				5/20/03			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.